

PROCEEDINGS OF SPIE

High-Power Lasers and Applications VII

Ruxin Li
Upendra N. Singh
Robert F. Walter
Editors

9–11 October 2014
Beijing, China

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SPIE

Volume 9266

Proceedings of SPIE 0277-786X, V. 9266

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

High-Power Lasers and Applications VII, edited by Ruxin Li, Upendra N. Singh,
Robert F. Walter, Proc. of SPIE Vol. 9266, 926601 · © 2014 SPIE
CCC code: 0277-786X/14/\$18 · doi: 10.1117/12.2181445

Proc. of SPIE Vol. 9266 926601-1

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Please use the following format to cite material from this book:

Author(s), "Title of Paper," in *High-Power Lasers and Applications VII*, edited by Ruxin Li, Upendra N. Singh, Robert F. Walter, Proceedings of SPIE Vol. 9266 (SPIE, Bellingham, WA, 2014) Article CID Number.

ISSN: 0277-786X

ISBN: 9781628413397

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

SPIE.org

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